

<b>Notice of References Cited</b>	Application/Control No. 10/779,743	Applicant(s)/Patent Under Reexamination KAWAMURA, ET AL.	
	Examiner Mike Qi	Art Unit 2871	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,812,231	09-1998	Kochi et al.	349/151
	B	US-5,847,781	12-1998	Ono et al.	349/44
	C	US-5,541,748	07-1996	Ono et al.	349/42
	D	US-6,310,667	10-2001	Nakayoshi et al.	349/42
	E	US-6,304,308	10-2001	Saito et al.	349/155
	F	US-2002/0109801	08-2002	Ono et al.	349/43
	G	US-2002/0009447	01-2002	Hooper et al.	424/147.1
	H	US-2002/0132385	09-2002	DOJO et al.	438/30
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.